

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|---------|--|---|------------------|---------|------------------|
| L1 | 241700 | sputter\$ | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L2 | 94415 | deposit\$4 with (hdp or hdpcvd or plasma) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L3 | 10185 | deposit\$4 with (hdp or hdpcvd or (high near3 plasma)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L4 | 4134 | L3 and L1 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L5 | 1744759 | semiconductor or (semi adj1 conductor) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L6 | 2542 | L4 and (chamber or insitu or (in-situ)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L7 | 2083 | L6 and L5 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L8 | 1 | ("6033981").PN. | US-PGPUB; USPAT | OR | OFF | 2006/09/17 17:02 |
| L9 | 1 | ("6046104").PN. | US-PGPUB; USPAT | OR | OFF | 2006/09/17 17:02 |
| L10 | 1 | ("20030139034").PN. | US-PGPUB; USPAT | OR | OFF | 2006/09/17 17:02 |

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|-----|-------|--|---|----|-----|------------------|
| L11 | 28 | ("5310700" "5393709" "5494854" "5545919" "5641712" "5665657" "5679606" "5721173" "5728621" "5817567" "5858870").PN. OR ("6033981").URPN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2006/09/17 17:02 |
| L12 | 93310 | frequency same (power or watt) same (bias or voltage) | US-PGPUB; USPAT | OR | ON | 2006/09/17 17:02 |
| L13 | 0 | L11 with (hdp or hdpcvd or (high near3 plasma)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L14 | 0 | L11 same (hdp or hdpcvd or (high near3 plasma)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L15 | 1243 | L12 same (hdp or hdpcvd or (high near3 plasma)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |
| L16 | 74477 | (metal or conductive) near2 line | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/09/17 17:02 |